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PATENT

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M. WATTS
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Whonchee Lee *et al.*

APPLICATION NO.: 09/888,002

FILED: June 21, 2001

FOR: **METHODS AND APPARATUS FOR
ELECTRICALLY AND/OR CHEMICALLY-
MECHANICALLY REMOVING
CONDUCTIVE MATERIAL FROM A
MICROELECTRONIC SUBSTRATE**

EXAMINER: Dung V. Nguyen

ART UNIT: 3723

CONF. No: 9049

Amendment in Response to Restriction Requirement

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

In response to the Office Action dated ^{TECHNOLOGY CENTER R3700} October 1, 2002, please amend the application as follows.

In the Claims

Please cancel claims 65-107, without prejudice to pursuing these claims in a continuation, divisional, continuation-in-part or other application. Please withdraw claims 36-64 without prejudice.

REMARKS

In the above referenced Office Action, the Examiner divided the claims into the following groups: I. Claims 1-64, drawn to a method for removing electrically conductive material from a microelectronic substrate; and II. Claims 65-107, drawn to an apparatus for removing conductive material from a microelectronic substrate.

In response, the applicants elect Group I without traverse. Non-elected claims 65-107 have been canceled. Applicants further elect Species 1, claims 1-35, without